



PATENT *ACE\$ Ifw*

Customer No. 22,852

Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Junji SUGAMOTO et al.)
Application No. 10/706,090) Group Art Unit: 2891
Filed: November 13, 2003) Examiner: Smith, Bradley
For: SEMICONDUCTOR WAFER)
TREATMENT METHOD,) Confirmation No.: 7292
SEMICONDUCTOR WAFER)
INSPECTION METHOD,)
SEMICONDUCTOR DEVICE)
DEVELOPMENT METHOD AND)
SEMICONDUCTOR WAFER)
TREATMENT APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office
Action mailed January 25, 2007. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter this response and
charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

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Dated: May 23, 2007

By: *See PR*

Selah C. Park
Reg. No. 57,127